



GAU2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Vishwanathan et al.

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Title: POLISHING PADS FOR CHEMICAL
MECHANICAL PLANARIZATION

Attorney Docket No.: 126

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Examiner:

Group Art Unit: 2812

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Payton
TO: 2001-10-01STATEMENT UNDER 37 CFR 1.97(e)

Sir:

The undersigned hereby certifies that either:

- (X) Each item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, not more than three months prior to the filing of the statement, or
- () No item of information contained in the Information Disclosure Statement
 - was cited in a communication from a foreign patent office in a counterpart foreign application, and
 - to the knowledge of the undersigned, after making reasonable inquiry, was known to an individual designated in 37 CFR 1.56 (c) more than three months prior to the filing of the Information Disclosure Statement.

Respectfully submitted,

Vishwanathan et al.

By Gerald K. Kita
Attorney/Agent for Applicant(s)
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